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RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE REQUESTED
GROUP 2861

PATENT

Attorney Docket
32739 M 008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CONFIRMATION NO. 5926

Applicant : Kensuke FUJIWARA
Serial No. : 09/280,518 Art Unit : 2861
Filed : April 5, 1999 Examiner : Hai-Chi-PHAM
For : LASER INTENSITY ADJUSTING METHOD

RESPONSE TO PAPER NO. 25

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir :

Entry and consideration of this Response courteously are solicited under 37 CFR §1.116. This paper is submitted in reply to the Office Action of July 15, 2003 and therefore was due by October 15, 2003. Accordingly, a Petition for a two-month extension of the response period, up to and including December 15, 2003, is submitted herewith. Please accept this paper as timely filed.

Please DO NOT ENTER

Hai Chi Pham

3/26/04

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